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Substitute for form 1449A/PTO				Complete if Known		
				Application Number	10/808,806	
INFORMATION DISCLOSURE			SURE	Filing Date	March 25, 2004	
STA	STATEMENT BY APPLICANT (use as many sheets as necessary)			First Named Inventor	Yiming Gu	
(use				Art Unit	1756	
				Examiner Name		
Sheet	1	of	2	Attorney Docket Number	IDT-1769	

U.S. PATENT DOCUMENTS						
Examiner Cite Initials* No.1	Ciro	Document Number	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where	
	Number - Kind Code <sup>2</sup> (if known)	WM-DD-YYYY	Applicant of Cited Document	Relevant Passages or Relevant Figures Appear		
CY		US-2003/0148198 A1		Lakkapragada et al.	-	
CY	<u> </u>	US-6,025,116		Grassmann, Andreas		
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	FOREIGN PATENT DOCUMENTS					
Examiner C	Cite	Foreign Patent Occument	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages	П
Initials*	No.1	Country Code <sup>3</sup> - Number <sup>4</sup> - Kind Code <sup>6</sup> (if known)	MM-DD-YYYY	Applicant of Cited Document	or Relevant Figures Appear	174
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Examiner Signature	/Christopher Young/ (12/27/2006)	Date Considered	12/27/2006			

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Substitute for form 1449B/PTO Complete if Known **Application Number** 10/808,806 **INFORMATION DISCLOSURE** Filing Date March 25, 2004 First Named Inventor Yiming Gu STATEMENT BY APPLICANT 1756 **Group Art Unit** (use as many sheets as necessary) Examiner Name of 2 2 **Sheet Attorney Docket Number** IDT-1769

OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No.	include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catatog, etc.), date, page(s), volume-Issue number(s), publisher, city and/or country where published.	τ²		
CY		Single wafer process to generate reliable swing", by Yiming Gu, Cynthia Zhu, John L. Sturtevant, Proc. SPIE Vol. 5038, p. 832-840, Metrology, Inspection, and Process Control for Microlithography XVII; May 2003, Daniel J. Herr, Ed.			
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Examiner Signature /Christopher Young/ (12/27/2006)	Date Considered	12/27/2006
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